

FILED VIA EFSWEB

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PATENT

Inventors:	Kei TASHIRO et al.	Docket No.:	29288.5600
Assignee:	JAPAN SCIENCE AND TECHNOLOGY CORPORATION		
Serial No.:	10/089,776	Confirmation No.	2614
Filing Date:	June 21, 2002	Art Unit:	1641
Title:	HIGH SENSITIVITY IMMUNOASSAY METHOD	Examiner:	Shafiqul Haq

AMENDMENT AND REPLY

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Commissioner:

In reply to the Final Office Action mailed on July 21, 2006, in which this Reply is filed within two months, please amend the above-identified application as follows

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.